



App. No. 10/823,116

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/823,116
Filing Date April 12, 2004
Inventor Kevin J. Torek et al.
Assignee Micron Technology, Inc.
Group Art Unit 1765
Examiner Deo, Duy Vu Nguyen
Attorney's Docket No. MI22-2559
Title: Methods of Removing Material from a Semiconductor Substrate

**RESPONSE TO APRIL 5, 2005 FINAL OFFICE ACTION TO ACCOMPANY FILING
OF A REQUEST FOR CONTINUED EXAMINATION**

To: Mail Stop RCE
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AMENDMENTS

Introductory Comments

In response to the Final Office Action of April 5, 2004, applicant amends and remarks as follows.